

DO NOT ENTER / OK TO ENTER
MDP 3/9/2005
2/7/2005



12/27/04

AF/ 2814
IFW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/072,658
Filing Date: February 7, 2002
Applicant: Tomoyuki Furuhashi et al.
Group Art Unit: 2814
Examiner: Marcos D. Pizarro-Crespo
Title: SEMICONDUCTOR DEVICE AND METHOD FOR
MANUFACTURING THE SAME
Attorney Docket: 9319S-000328

Mail Stop AF
Director of The United States Patent and Trademark Office
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT AFTER FINAL

Sir:

In response to the Office Action mailed September 30, 2004, please amend the application as follows and consider the remarks set forth below.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks begin on page 8 of this paper.